

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 245810US2TTCRD DIV		SERIAL NO. 10/726,583 New Divisional Application	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Yoshinori IIDA, et al.			
				FILING DATE Herewith		GROUP Unknown	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE	
OG	AA	6,163,061	12/19/2000	Y. IIDA			
OG	AB	6,507,365	01-2003	NAKAMURA et al.			
OG	AC	2001/0005227 A1	06-2001	EGAWA et al.			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO			
	AO						
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
OG	AW	Ishikawa, T. et al., "Low-Cost 320 x 240 Uncooled IRFPA Using Conventional Silicon IC Process," SPIE, Vol. 3698, Apr. 1999, pps. 556-564.					
	AX						
	AY						
	AZ						
				<input type="checkbox"/> Additional References sheet(s) attached			
Examiner <i>OGH GGH</i>				Date Considered 03/24/04			
<small>*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							